

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE****FAX RECEIVED**

Inventors: Blaine R. Spady; John D. Heaton

MAR 30 2006

Assignee: Nanometrics Incorporated

**OFFICE OF PETITIONS**

Title: Metrology/Inspection Positioning System

Serial No.: 09/458,123

Filing Date: December 8, 1999

Examiner: Gordon Stock

Group Art Unit: 2877

Docket No.: NAN035 US

Confirmation No.: 8470

Santa Clara, California

March 30, 2006

Mail Stop Petition  
Commissioner For Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT**

Dear Sir:

This Amendment is filed with a Request for Continued Examination and a Petition to Withdraw from Issuance under 37 C.F.R. §1.313(c). Please enter the following amendment before taking action on the merits of the above-referenced application.

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